



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:

Randy Skocypec et al.

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Art Unit: 1746

Serial No.: 10/622,307

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Examiner: Bibi Sharidan Carrillo

Filed: July 18, 2003

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Docket: ITL.1017US
P16704

For: Cleaning Semiconductor
Wafers

§

Assignee: Intel Corporation

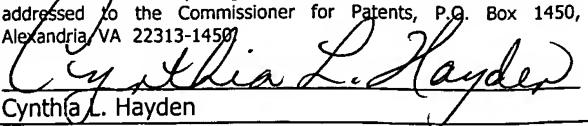
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Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Prior to the receipt of an office action, please amend the above-referenced patent application as follows:

Date of Deposit: February 7, 2006
I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Cynthia L. Hayden